

INFORMATION DISCLOSURE STATEMENT

Applicant	:	Masahiko Nakamori et al.
App. No	:	10/536,621
Filed	:	May 26, 2005
For	:	POLISHING PAD AND METHOD OF PRODUCING SEMICONDUCTOR DEVICE
Examiner	:	MacArthur, Sylvia R.
Art Unit	:	1792
Conf No.	:	9275

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 2 references, of which 2 are enclosed/submitted.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)

I hereby certify that each item of information contained in this Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c), however, the Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: February 15, 2011

By: /daniel altman/

Daniel E. Altman
Registration No. 34,115
Attorney of Record
Customer No. 20995
(949) 760-0404

Application No.: 10/536,621
Filing Date: May 26, 2005

10711698